

IRDM 0284 00019

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


Applicant : Miles, et al.
Appl. No. : 10/606,001
Filed : June 24, 2003
For : THIN FILM PRECURSOR
STACK FOR MEMS
MANUFACTURING
Examiner : Hasan, Mohammed A.
Group Art Unit : 2873

CERTIFICATE OF FAX TRANSMISSION

I hereby certify that this correspondence and all
marked attachments are being transmitted via
facsimile to the USPTO Via Fax No. (571)
273-2885 on the date shown below:

March 2, 2006

(Date)


Mark M. Abumeri, Reg. No. 43,458AMENDMENT AFTER ALLOWANCE UNDER 37 CFR §1.312

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Allowance mailed December 2, 2005, please amend the
above-identified application as follows.

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.

Enter
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Formal
Matters
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M.H
5/2/06